



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of)
)
Kazuo MAEDA) Examiner: Quach
)
Serial No.: 09/519,599) Art Unit: 2814
)
Filed: March 6, 2000)
)
For: METHOD AND APPARATUS FOR)
FORMING AN INTERLAYER)
INSULATING FILM AND)
SEMICONDUCTOR DEVICE)

PETITION FOR EXTENSION OF TIME UNDER 37 CFR 1.136

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

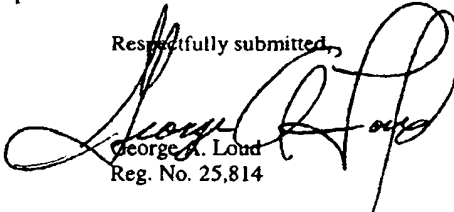
Sir:

It is respectfully requested that the time period for filing a response to the office action of April 23, 2003, initially set to expire July 23, 2002, be extended one month up to and including August 23, 2003. The requisite \$110.00 fee for the requested extension is herewith attached.

Any additional fees may be charged to Deposit Account No. 12-2174.

18/15/2003 CHUYEN 00000056 09519599
11 FC1251 110.00 09

Respectfully submitted,


George A. Loud
Reg. No. 25,814

Date: August 14, 2003

LORUSSO, LOUD & KELLY
3137 Mount Vernon Avenue
Alexandria, VA 22305

(703) 739-9393

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